Corrosion Resistance of Ceramic-coated Stainless Steel in a Br₂–O₂–Ar Atmosphere

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Abstract

Coatings of SiC/TiC compositional graded film (FGM), m-HfO₂ and c-HfO₂ films on stainless steel (SUS304) plates have been investigated as candidate materials for 'UT-3' which is an effective process of hydrogen production through thermochemical decomposition of water. Changing the source gas concentration leads to composition control in TiC-SiC composite films. Cracks in the films could not be avoided in either the TiC-coated SUS304 nor the SiC-TiC double layer-coated SUS304. However the SiC/TiC FGM-coated SUS304 had no cracks. Corrosion of the TiC and SiC-20 mol%TiC double-layer-coated SUS304 in the Br₂-O₂-Ar atmosphere was mainly caused by oxidation of the TiC film and SUS304. The SiC/TiC FGM-coated SUS304 showed superior corrosion resistance in isothermal and cyclic heating conditions.

m-HfO₂ and c-HfO₂ $(7\cdot1-44\cdot5 \text{ mol}\% Y_2O_3)$ were attained by the changing of $Y(DPM)_3$ gas concentration. XRD measurement shows the monoclinic and cubic HfO₂. Both plate-like and columnar texture in the m-HfO₂ and c-HfO₂ films were observed. m-HfO₂, in which columnar texture, coated SUS304 showed the excellent corrosion resistance in Br_2 -O₂-Ar atmosphere under heat cyclic conditions. This is thought to be due to the effects of columnar texture on the thermal stress relaxation, and of the excellent corrosion resistance of the m-HfO₂.

1 Introduction

Hydrogen gas (H₂) is expected to be used as a new energy source because conventional fuels tend to destroy the natural environment. One of the methods to produce H₂ is the thermochemical decomposition of water called 'UT-3'. The 'UT-3' process causes high temperature corrosion of structural materials because highly corrosive gases such as O₂, Br₂ and

HBr might be used at temperatures from 500 to 1000 K. Considering practical applications, metals should be used as structural materials. However, no metal is known to resist the corrosive conditions caused by 'UT-3'. Ceramic-coated metals are expected to be candidate structural materials. Titanium carbide (TiC) films are highly adherent to metals, and silicon carbide (SiC) is resistant to corrosion. CVD is the most suitable method for the surface modification of metals, because it allows the preparation of dense and adherent films. On the other hand, Functionally Gradient Materials (FGMs) having an excellent thermal stress relaxation property are well known as thermal barrier materials.²⁻⁷ In the present work, single-layer TiC or SiC, double-layer SiC and TiC, and SiC/TiC FGM coatings were placed on stainless steel (SUS304) using the CVD method. On the other hand, HfO₂ has a superior thermal expansion matching to the stainless steel. Thus, m-HfO₂ and c-HfO₂(Y₂O₃) coatings were also deposited on the SUS304 using the CVD method. The corrosion behaviour of these materials in Br₂-O₂-Ar atmosphere was investigated.

2 Experimental

2.1 Preparation of TiC, SiC and SiC-TiC composite films

Stainless steel (SUS304) plates (15 mm in diameter and 2 mm in thickness) were used as substrates. Source gases TiCl₄, CH₃SiCl₃(MTS), CH₄ and H₂ were introduced into a hot-wall type CVD reactor. Deposition temperature ($T_{\rm dep}$) and total gas pressure ($P_{\rm tot}$) were fixed at 1323 K and 0·1 MPa, respectively. H₂ gas flow rate was kept at 8·3 × $10^{-6} {\rm m}^3 {\rm s}^{-1}$. TiCl₄ gas flow rate was changed from 0 to $3\cdot3 \times 10^{-7} {\rm m}^3 {\rm s}^{-1}$, MTS gas flow rate from 0 to $1\cdot6 \times 10^{-6} {\rm m}^3 {\rm s}^{-1}$. The ratio of CH₄ to MTS was kept at $1\cdot7$ to fabricate the TiC-containing films. The structure of CVD films was examined by XRD (Rigaku: RAD-C), the surface and the

Table 1. Preparation conditions of m-HfO₂

Substrate temperature (T_{sub}) , T/K	873~1173
Total gas pressure (P_{tot}) , P/kPa	1.3
Gas flow rate, $FR/10^{-6}$ m ³ s ⁻¹	
Ar for Hf(DPM) ₄	1.7
O_2	1.7
Temperature of Hf(DPM) ₄ reservoir (THf), T/K	453
Deposition time (T_{dep}) , t/ks	1.2~4.8

cross-sectional texture observed by SEM spectroscopy (Akashi:ALPHA-30). SiC and TiC content in the films were determined by EPMA measurement as substitutions for the Si (Ka) and Ti (Ka) intensity.

2.2 Preparation of SiC/TiC FGM film

On the basis of the preparation conditions of SiC-TiC composite films, SiC/TiC FGM films were fabricated on SUS304 by changing the source gas concentration ('a'=MTS/(TiCl₄+MTS)) at $T_{\rm dep}$ =1323 K and $P_{\rm tot}$ =0·1 MPa. 'a' was changed stepwise from 0 for 4 h, 0·7 for 1 h to 1·0 for 1 h. The surface and cross-sectional texture were observed by SEM.

2.3 Preparation of m- and c-HfO₂ films

(100)Si and Stainless steel (SUS304) plates (15 mm in diameter and 2 mm in thickness) were used as substrates. Source gases $Hf(DPM)_4$, $Y(DPM)_3$, O_2 and Ar were introduced into a hot-wall type CVD reactor. Tables 1 and 2 demonstrate the CVD conditions. Deposition temperature (T_{dep}) and total gas pressure (P_{tot}) were fixed at 1073 K and 13 kPa, respectively. The structure of CVD films was examined by the XRD, the surface and the cross-sectional texture observed by the SEM. Film composition was determined by ICP and XRF measurements.

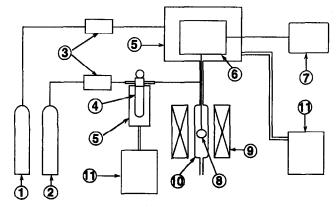


Fig. 1. Schematic diagram of corrosion rate measurement: (1) Ar gas, (2) O₂ gas, (3) mass flow meter, (4) Br₂ reservoir, (5) constant temperature bath, (6) electric balance, (7) computer, (8) specimen, (9) electric furnace, (10) quartz tube, (11) cool pump.

Table 2. Preparation conditions of c-HfO₂

Substrate temperature (T_{sub}) , T/K	873~1073
Total gas pressure (P_{tot}) , P/kPa	1.3
Gas flow rate, $FR/10^{-6}m^3s^{-1}$	
Ar for Hf(DPM) ₄	1.7
Ar for $Y(DPM)_3$	1.7
O_2	1.7
Temperature of Hf(DPM) ₄ reservoir (THf), T/K	433~463
$Y(DPM)_3$ reservoir (THf), T/K	403~421
Deposition time (T_{dep}) , t/ks	1.2~7.2

2.4 Measurement of corrosion rates

Figure 1 demonstrates the experimental set-up for the evaluation of corrosion rate. The specimens were suspended by a platinum wire in an electric furnace. Weight changes during corrosion were continuously measured using an electric balance connected to a computer (NEC:PC-9801). The electric balance was kept at 298 K in a constant temperature box. Ar gas was passed through the electric balance and introduced into the quartz tube. O2 gas containing Br2 was introduced from the bottom of the balance box into the quartz tube. The Br₂ reservoir was maintained at 288 K. The corrosion temperature (T_{cor}) was kept at 1173 K in isothermal experiments. In the case of cyclic heating, T_{cor} was cyclically changed from 1173 to 773 K under the same gas flow rates in isothermal corrosion experiment.

3 Results and discussion

3.1 Preparation of TiC, SiC and SiC-TiC composite films

The possibility of the CVD method to control film composition was investigated. Figure 2 shows the relationship between input gas concentration and film composition. SiC content in the film increases

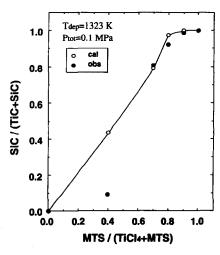


Fig. 2. Relationship between input gas concentration and film composition compared with theoretical film composition.

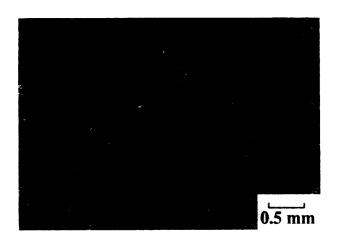
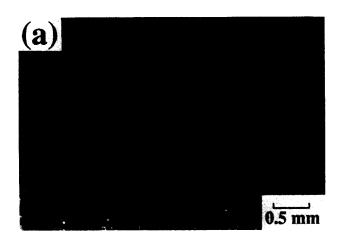


Fig. 3. SEM photograph of deposited surface of the SiC and TiC double-layer-coated SUS304.

with increasing MTS concentration. Figure 2 also demonstrates the theoretical composition of the films calculated using JANAF data⁸ under the thermodynamic equilibrium conditions based on a free energy minimisation method. Experimental compositions of the films agree well with those of the calculated values except at the *a* of 0.4. The lower value is thought to be due to the kinetics of the CVD process. These data show that SiC content in the SiC-TiC composite films can be controlled.



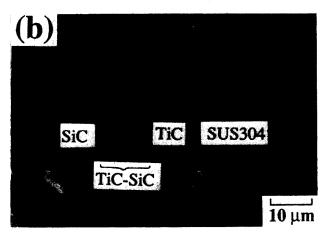


Fig. 4. SEM photographs of the SiC/TiC FGM-coated SUS304. (a) Surface of the specimen. (b) Cross-section of the specimen.

While direct coating of TiC on the SUS304 was achieved, the SiC-TiC composite film was not obtained on the SUS304 because Fe₃Si and FeSi₂ formed as a result of easy reaction between MTS and SUS304. This result demonstrates the impossibility of direct coating of SUS304 with SiC. Reaction protection layers such as TiC are indispensable between SiC and SUS304. An SiC coating on the TiC-coated SUS304 was attempted. Figure 3 shows the SEM photograph of the surface of the SiC/TiC double layer-coated SUS304. SiC was deposited on the TiC interlayer. Cracks were observed on the surface of the TiC-coated SUS304. Thermal expansion coefficients of TiC, SiC and SUS304 are 7.6×10^{-6} , 4.3×10^{-6} , 1.73×10^{-6} 10⁻⁵K⁻¹, respectively. As shown in Fig. 4, cracking also occurred in the SiC film as a result of the mismatch between thermal expansion coefficients of SiC and SUS304. Even if the thicknesses of SiC and TiC were ranged from 2 to 20 μ m, cracking could not be avoided.

3.2 Preparation of an SiC/TiC FGM film

For the purpose of residual thermal stress relaxation and the protection of crack formation, continuous change of the thermal expansion coefficients, so-called Functionally Gradient Materials (FGMs) might be useful. Figure 4 shows the SEM photographs of the surface and the cross-section of the SiC/TiC FGM-coated SUS304.

Compositional graded layer from TiC to SiC forms on the SUS304. Despite the mismatch of thermal expansion coefficients between SiC, TiC and SUS304, no cracks in the SiC/TiC FGM-coated SUS304 appear on the deposited surface, as shown in Fig. 4. The result suggests that the introduction of the compositional gradation between the SiC and TiC layers reduce the surface tensile stress of the SiC/TiC FGM-coated SUS304.

3.3 Synthesis of m-HfO₂ films

The m-HfO₂ formation was confirmed by X-ray diffraction (JCPDS card No. 34-104). The thickness increased from 0.8 to 3.2 μ m with increasing $T_{\rm dep}$ from 873 to 1073 K, and was kept constant above 1073 K. The SEM photographs of the surface of m-HfO₂ deposited on the (100)Si substrate are shown in Fig. 5. Figure 5(a) shows a plate-like dense m-HfO₂ film deposited at a $T_{\rm dep}$ of 973 K and at a $t_{\rm dep}$ of 1.2 ks, which has cracks and detached from the substrate. On the other hand, as shown in Fig. 5(b), the film deposited at a $T_{\rm dep}$ of 1073 K and at a $t_{\rm dep}$ of 2.4 ks has a columnar texture. Figure 5(b) also shows the dense layer around the interface film-substrate with no cracks and no detachment from the substrate.





Fig. 5. SEM photographs of the plate-like (a) and columnar (b) m-HfO₂.

As shown in Fig. 5, a plate-like dense film was deposited in the $T_{\rm dep}$ range from 873 to 973 K. Its XRD pattern, characterised by broad peaks, demonstrated the lower degree of crystallisation. On the other hand, the film deposited in the $T_{\rm dep}$ range from 1023 to 1173 K has a columnar structure and showed relatively higher crystallinity.

3.4 Synthesis of c-HfO₂ films

The film deposited at a $T_{\rm dep}$ of 1073 K, a $T_{\rm Hf}$ of 453 K, a $T_{\rm Y}$ of 406 K, a $t_{\rm dep}$ of 2.4 ks, $FA_{\rm Ar}$ of 1.7 \times 10⁻⁶ m³s⁻¹, FR_{O₂} of 1.7 \times 10⁻⁶ m³s⁻¹, and at a $P_{\rm tot}$ of 1.3 kPa, was identified as the c-HfO₂ (JCPDS card No. 24-1406).

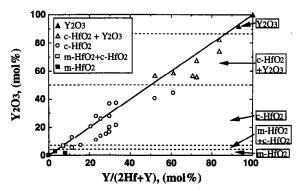


Fig. 6. Relationship between input gas concentration and film composition.

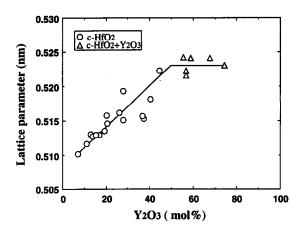


Fig. 7. Relationship between film composition and lattice parameter of c-HfO₂.

Figure 6 shows the relationship between input gas molar ratio and the Y_2O_3 content in the films. The straight line in Fig. 6 demonstrates the ideal Y_2O_3 content in the films, obtained by the following reaction:

 $xHf(DPM)_4 + yY(DPM)_3 + O_2 \rightarrow xHfO_2 + (y/2)Y_2O_3 + (Volatile compounds)$

 Y_2O_3 content was determined by ICP method in which the substitution of Y content in the films. m-HfO₂+c-HfO₂) composites were deposited in the Y_2O_3 range from 5.03 to 6.52 mol%, single c-HfO₂ phase in the Y_2O_3 range from 7.1 to 44.5 mol%, c-HfO₂+Y₂O₃ composites in the Y_2O_3 range from 56.6 to 82.3 mol%.

The relationship between Y_2O_3 content and the lattice parameters measured by (400) X-ray intensity is shown in Fig. 7. The (400) peak of the substrate was used as an inner standard. The lattice parameters have a tendency to increase with increasing Y_2O_3 content.

3.5 Corrosion behaviour

(a) SiC-TiC composites and SiC/TiC FGM

Weight loss of the TiC-coated SUS304 during corrosion experiment was observed at T_{cor} =1173 K, $P_{\rm Br_2} = 4.4$ kPa and $P_{\rm O_2} = 0.1$ kPa. As large quantities of O₂ gas might be generated in the 'UT-3' process, corrosion experiments should be conducted at large O₂ gas concentration including Br₂ gas. Figure 8 shows the relationship between time and weight change by the corrosion at $T_{cor}=1173$ K, $P_{Br_2} = 4.4$ kPa and $P_{O_2} = 46$ kPa (isothermal corrosive condition). All the specimens revealed weight gain in this corrosive condition. The surfaces of the TiC-coated SUS304, TiC and SiC-20 mol% TiC double-layer-coated SUS304, and SiC and TiC double-layer-coated SUS304 after the corrosion at T_{cor} =1173 K, P_{Br_2} = 4.4 kPa and P_{O_2} = 46 kPa were observed by SEM. The surface of the TiC was extremely damaged by corrosion. In the case of the SiC-20 mol% TiC, the surface

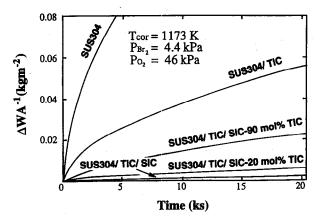


Fig. 8. Relationship between time and weight gain of the SiC-TiC composites by the corrosion at $T_{\rm cor}$ = 1173 K, $P_{\rm Br_2}$ = 4.4 kPa and $P_{\rm O_2}$ = 46 kPa.

texture became porous and rough. This result occurs due to the difference of corrosion rate between SiC and TiC. SiC is likely to have excellent corrosion resistance. Phases formed after corrosion were investigated by using XRD. TiO₂, Fe₂O₃ and Fe₃O₄ were observed at the surface of the TiC-coated SUS304. The SUS304 substrate was oxidised by corrosive Br₂-O₂ that diffused through the cracks of the TiC film. On the other hand, only TiO₂ was formed on the TiC/SiC-20 mol% TiC double-layer-coated SUS304.

Figure 9 shows the dependence of corrosion rate on the film composition in the SiC-TiC composite system. Clearly, the addition of SiC into the TiC film improves the corrosion resistance of TiC. SiC provide high corrosion resistance, but the TiC/SiC-20 mol% TiC can not be used as the surface material in 'UT-3', because a corrosion of TiC in the composite film is indispensable. To compare the corrosion resistance of TiC/SiC-20 mol% TiC double-layer-coated SUS304 with that of the SiC/TiC FGM-coated SUS304, a corrosion experiment with different heat cycles was attempted.

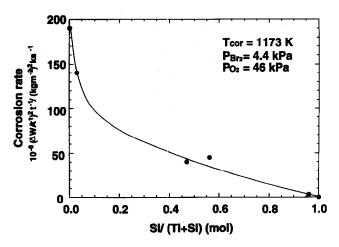


Fig. 9. Dependence of corrosion rate on the composition of SiC-TiC composite films by the corrosion at $T_{\rm cor} = 1173$ K, $P_{\rm Br_2} = 4.4$ kPa and $P_{\rm O_2} = 46$ kPa.

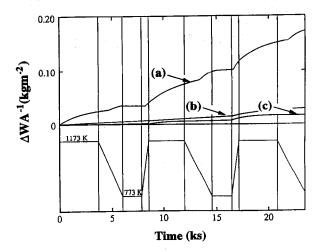


Fig. 10. Relationship between time and weight gain by the corrosion under the cyclic test between 1173 K to 773 K at $P_{\rm Br_2}=4.4$ kPa and $P_{\rm O_2}=46$ kPa. (a) TiC-coated SUS304; (b) TiC/SiC-20 mol% TiC double-layer-coated SUS304; (c) SiC/TiC FGM-coated SUS304.

Figure 10 shows the relationship between time and weight gain by the corrosion under the cyclic test between 1173 and 773 K at $P_{\rm Br_2}$ = 4.4 kPa and $P_{\rm O_2}$ = 46 kPa. TiC-coated SUS304 has less corrosion resistance. Both TiC/SiC-20 mol% TiC double-layer-coated SUS304, and the SiC/TiC FGM-coated SUS304 were covered with SiC on the surface.

Cracks in the film could not be avoided in the SiC/TiC double-layer-coated SUS304. However, the SiC/TiC FGM-coated SUS304 had no cracks (Figs 3 and 4). The result of corrosion experiments in the heat cyclic condition shows the capability of FGM coating to achieve thermal stress relaxation and corrosion resistance.

(b) m- and c- HfO_2 films

Figure 11 shows the weight change of the HfO_2 -coated-SUS304 under the isothermal corrosion experiments at a $T_{\rm cor}$ of 1173 K, a $P_{\rm Br_2}$ of 4.4 kPa, a $P_{\rm O_2}$ of 46 kPa, a $P_{\rm tot}$ of 0.1 MPa, and at a $t_{\rm cor}$ of 21.6 ks. The specimens used for the corrosion experiments were the columnar m-HfO₂ with film thickness of 14 and 4 μ m, the plate-like m-HfO₂ with thickness of 14 μ m, and bare SUS304. c-HfO₂-coated SUS304 was not corrosion resistant, while m-HfO₂-coated SUS304 showed a superior corrosion resistance.

XRD measurements of bare SUS304 and c-HfO₂-coated SUS304 showed that after the corrosion experiments, Fe₂O₃, Fe₃O₄ and Cr₂O₃ were formed. On the surface of the specimens after the corrosion experiments, the detachment of oxide scale from the SUS304, with a thickness of 0·19 μ m could be observed. In the case of c-HfO₂-coated SUS304, the detachment of the film from

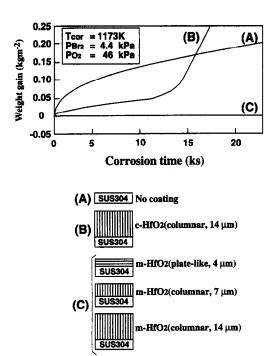


Fig. 11. Relationship between time and weight gain of m-HfO₂-coated SUS304 by the corrosion at $T_{\rm cor} = 1173$ K, $P_{\rm Br2} = 4.4$ kPa and $P_{\rm O2} = 46$ kPa (isothermal condition).

the SUS304 partially occurred. The corrosion and the detachment of the film might occur around the interface of c-HfO₂ film and SUS304.

The corrosion resistance of the m-HfO₂-coated SUS304, which revealed the superior corrosion resistance under isothermal conditions, was investigated by the heat-cyclic corrosive test.

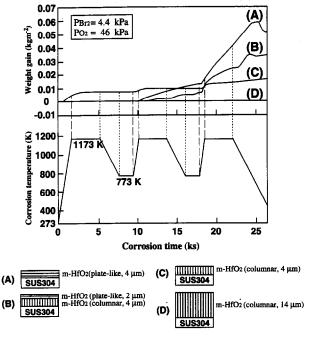


Fig. 12. Relationship between time and weight gain by the corrosion under the cyclic test between 1173 K to 773 K at $P_{\rm Br_2}=4.4$ kPa and $P_{\rm O_2}=46$ kPa. (a) m-HfO₂ (plate-like, 4 μ m); (b) m-HfO₂ (columnar, 4 μ m; plate-like, 2 μ m); (c) m-HfO₂ (columnar, 4 μ m); (d) m-HfO₂ (columnar, 14 μ m).

Figure 12 shows the temperature change and the experimental results of the weight change of m-HfO₂-coated SUS304. The columnar m-HfO₂ (14 μ m) coated SUS304 had superior corrosion resistance. Corrosion resistance decreased in the order: columnar m-HfO₂(4 μ m), m-HfO₂ (texture changed from columnar to plate-like), plate-like m-HfO₂.

The examination of the surfaces of plate-like m-HfO₂ (4 μ m in thickness) and columnar m-HfO₂ (14 μ m in thickness) by SEM after the cyclic heating corrosion test, showed that the excellent corrosion resistance of the 14 μ m-columnar m-HfO₂ coated SUS304, was related to the absence of cracks and detachment from the substrate. This is thought to be due to the effects of columnar texture on the thermal stress relaxation, and of the excellent corrosion resistance of the m-HfO₂.

4 Conclusions

Coatings of TiC, SiC-TiC, SiC/TiC FGM, m-HfO₂ and c-HfO₂ on stainless steel (SUS304) using CVD method were examined as possible corrosion resistant structural materials for 'UT-3.' The corrosion resistance of these materials in a Br₂-O₂-Ar corrosive atmosphere was investigated. The following results were obtained:

Changing the source gas concentration leads to composition control in the TiC-SiC composite films. The composition of TiC-SiC films prepared at a deposition temperature of 1323 K and at a total gas pressure of 0.1 MPa agreed with calculations. The SiC-20 mol% TiC composite film was prepared at a MTS/(TiCl₄ + MTS) of 0.7. Cracks in the films after CVD could not be avoided in either the TiC-coated or the SiC, TiC double-layercoated SUS304. However, both the TiC and SiC-20 mol% TiC double-layer-coated SUS304, and the SiC/TiC FGM-coated SUS304 had no cracks. Corrosion of the TiC and SiC-20 mol% TiC double-layer-coated SUS304 was mainly caused by oxidation of the TiC film and SUS304. SiC/TiC FGM-coated SUS304 showed superior corrosion resistance in isothermal and cyclic heating conditions.

Cracks in the m- and c-HfO₂ films after CVD could not be avoided in neither plate-like m-HfO₂ nor plate-like c-HfO₂. Columnar m-HfO₂-coated or columnar c-HfO₂-coated SUS304 had no cracks. Corrosion of the c-HfO₂-coated or plate-like-m-HfO₂-coated SUS304 was mainly caused by oxidation of the SUS304. Columnar m-HfO₂-coated SUS304 showed superior corrosion resistance in isothermal and cyclic heating conditions. This is

thought to be due to the effects of columnar texture on the thermal stress relaxation, and of the excellent corrosion resistance of the m-HfO₂.

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